



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Minoru KATAYAMA et al.

Application No.: 09/690,590

Filed: October 18, 2000

Group Art Unit: 2856

Examiner: M. Cygan

Docket No.: 107612

For: SURFACE TEXTURE MEASURING MACHINE,
LEVELING DEVICE FOR SURFACE TEXTURE
MEASURING MACHINE AND ORIENTATION-
ADJUSTING METHOD OF WORKPIECE OF
SURFACE TEXTURE MEASURING MACHINE

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination and entry and consideration of the June 10, 2003 Amendment After Final Rejection submission. The above-identified application was filed on or after June 9, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 143886 in the amount of ☒ \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Richard J. Kim
Registration No. 48,360

07/08/2003 EAREGAY1 00000172 09690590

02 FC:1801

750.00 OP

JAO:RJK/mdw

Date: July 7, 2003

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

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